



P27346.A03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Docket No. P27346

K. CHENG et al.

Serial No.: 10/706,061

Group Art Unit: No. 2812

Filed: November 13, 2003

Examiner: S. D. Isaac

For: STRAINED SILICON ON A SiGe ON SOI SUBSTRATE

AMENDMENT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Sir:

Please amend the above-identified application as follows.

A listing of claims is set forth on pages 2-7.

Remarks begin on page 8.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 09-0458.